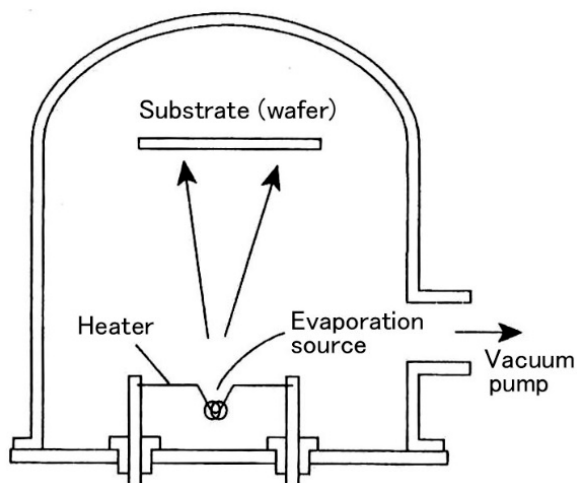
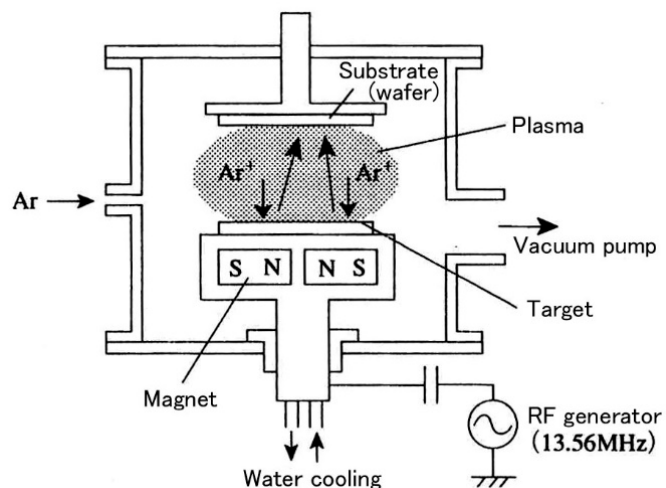


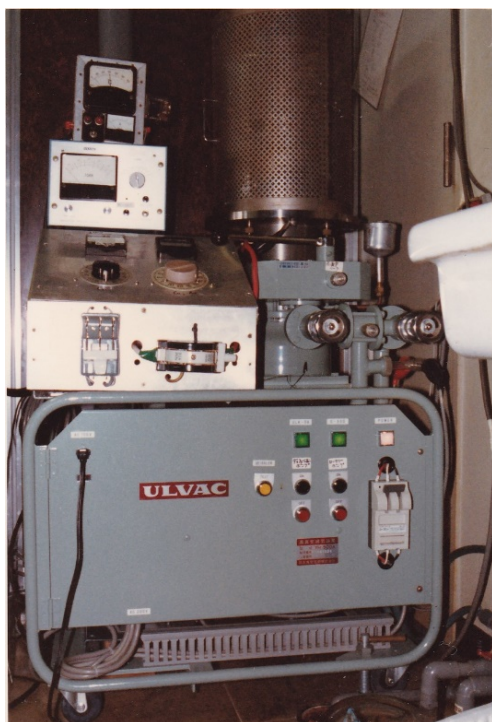
## 5 Physical vapor deposition (PVD (evaporation, sputtering))



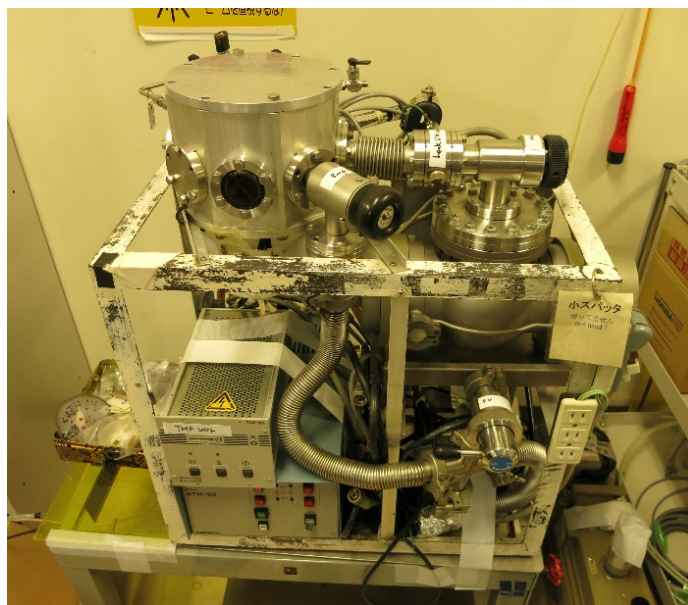
Principle of evaporation



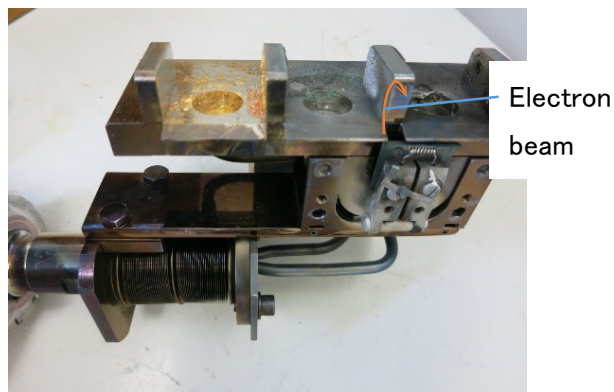
Principle of sputter deposition



Evaporator



Sputtering machine



Electron beam evaporator (exhibited)



Parylene (Polyparaxylylene) deposition